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Date of Signature and Deposit: September 26, 2001

Adam J. Faru
Attorney of Record



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Richard D. Harris
Serial No.: 09/843,545
Filed: April 26, 2001
For: Method for Fabricating an Isolated Microelectromechanical System (MEMS) Device Using an Internal Void
Group Art Unit: 2812
Docket No.: 01AB021

INFORMATION DISCLOSURE STATEMENT

Commissioner For Patents
Washington, D.C. 20231

Sir:

This is an Information Disclosure Statement pursuant to 37 C.F.R. §§ 1.97 and 1.98. It is Applicants' understanding that a first Office Action on the merits has not yet been mailed in this application, and that therefore 37 C.F.R. § 1.97(b) is applicable (so that this art may be considered without further requirements).

In the event that a first Office Action has been mailed having a mailing date prior to the filing of this Statement, thereby rendering 37 C.F.R. § 1.97(b) inapplicable, Applicants hereby, pursuant to Rule 97(c), authorize the payment of \$240.00 by charge to Deposit Account 17-0055 in order to permit consideration of this art. The Commissioner is also hereby authorized to deduct any other necessary fees needed for consideration of this art from Deposit Account No. 17-0055.

1. List

The attached form PTO-1449 constitutes the required list of supplied publications.

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2. Copies

Attached hereto is a legible copy of each item listed on the form PTO-1449.

Respectfully submitted,

RICHARD D. HARRIS

By: Adam J. Forman

Adam J. Forman, Esq.
Attorney for Applicant
Quarles & Brady
411 E. Wisconsin Avenue, Suite 2040
Milwaukee WI 53202-4497
(414) 277-5405
Reg. No. 46,707

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